

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent for: )  
Mark W. Miles ) Examiner: Barreca, Nicole M.  
Serial No.: 10/074,562 ) Art Unit: 1756  
Filed: February 12, 2002 )  
For: METHOD FOR FABRICATING A STRUCTURE )  
FOR MICROELECTROMECHANICAL )  
SYSTEMS (MEMS) DEVICE )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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TC 1700

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Dear Sir:

In response to the Office Action dated 6/18/03, Applicant respectfully request that the above-identified application be amended as follows and that the following remarks be considered.

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

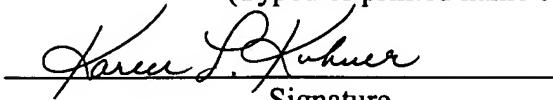
October 20, 2003

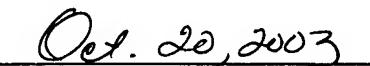
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